

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/618,067 Confirmation No. 4314
Applicant : Jifa Hao, et al.
Filed : July 11, 2003 Art Unit: 2822
Title : DENSE TRENCH MOSFET WITH DECREASED ETCH
SENSITIVITY TO DEPOSITION AND ETCH PROCESSING
Examiner : Rose, Kiesha L.
Docket No. : 3016429 (17732.6357.003)
Customer No. : 44,331

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

Responsive to the November 16, 2007 final Office Action, Applicants submit the following Remarks:

Remarks begin on page 2 of this paper.